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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

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|--|---------------------------|--|-----------------|----------------------------------|------------------|
| APPL NUM 10076818 | FILING DATE 02/14/2002 | CLASS 257 | SUBCLASS 67E | GAU 2811 | EXAMINER 2824 |
| **APPLICANTS: Kelkar Nikhil, Nguyen Luu. | | | | | |
| **CONTINUING DATA VERIFIED: | | | | | |
| ** FOREIGN APPLICATIONS VERIFIED: | | | | | |
| PG-PUB | | DO NOT PUBLISH <input type="checkbox"/> | | RESCIND <input type="checkbox"/> | |
| Foreign priority claimed | | <input type="checkbox"/> yes <input type="checkbox"/> no | | ATTORNEY DOCKET NO | |
| 35 USC 119 conditions met | | <input type="checkbox"/> yes <input type="checkbox"/> no | | NSC1P229/P05148 | |
| Verified and Acknowledged Examiners's initials | | | | | |
| TITLE : Apparatus and method for scribing semiconductor wafers using vision recognition | | | | | |

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|--|-----------|---------------------------|----------------------|
| NOTICE OF ALLOWANCE MAILED | | CLAIMS ALLOWED | |
| | | Total Claims | Print Claim for O.G. |
| ISSUE FEE | | DRAWING | |
| Amount Due | Date Paid | Sheets Drwg. | Figs.Drwg. |
| | | Print Fig. | |
| <input type="checkbox"/> TERMINAL DISCLAIMER | | Application Examiner | |
| | | PREPARED FOR ISSUE | |
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